

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. Of: SAMUKAWA et al.

Serial No.: 10/501,351

Filed: July 14, 2004

For: On-Wafer Monitoring System

Group: 1792 Confirmation No. 7535

EXAMINER: Dhingra, Rakesh Kumar DOCKET: SHIG CPTA0502FE

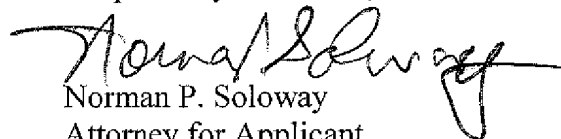
MAIL STOP ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INTERVIEW SUMMARY**

Dear Sir:

The Interview Summary attached to the Notice of Allowability and Notice of Allowance mailed December 23, 2008 accurately reflects the substance of the December 10, 2008 interview.

Respectfully submitted,

  
Norman P. Soloway  
Attorney for Applicant  
Reg. No. 24,315

**CERTIFICATE OF ELECTRONIC FILING**

I hereby certify that this correspondence is being deposited with the United States Patent Office via the electronic filing procedure on January 8, 2009.

By: 

NPS:kg

HAYES SOLOWAY P.C.  
3450 E. SUNRISE DRIVE,  
SUITE 140  
TUCSON, AZ 85718  
TEL. 520.882.7623  
FAX. 520.882.7643

175 CANAL STREET  
MANCHESTER, NH 03101  
TEL. 603.668.1400  
FAX. 603.668.8567